

INFORMATION DISCLOSURE STATEMENT

Applicant	:	Liu et al.
App. No.	:	Unknown
Filed	:	Herewith
For	:	METHOD FOR MANUFACTURE OF MAGNETO-RESISTIVE BIT STRUCTURE
Examiner	:	Unknown
Group Art Unit	:	Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

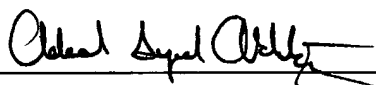
Enclosed is form PTO-1449 listing eight references that are of record in U.S. patent application No. 09/999,684, filed October 30, 2001, which is the parent of this divisional application, and is relied upon for an earlier filing date under 35 U.S.C. § 120. Copies of the references are not submitted pursuant to 37 C.F.R. § 1.98(d).

This Information Disclosure Statement is being filed with an RCE or within three months of the filing date of this application and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: December 11, 2003

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FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)	ATTY. DOCKET NO. MICRON.230DV1	APPLICATION NO. Unknown
	APPLICANT Liu et al.	
	FILING DATE Herewith	GROUP Unknown

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
	1	4,731,757	3/15/88	Daughton et al.			
	2	4,780,848	10/25/88	Daughton et al.			
	3	4,897,288	01/30/90	Jenson			
	4	5,496,759	3/5/96	Yue et al.			
	5	5,569,617	10/29/96	Yeh et al.			
	6	6,381,171 B1	4/30/02	Inomata et al.			
	7	6,487,110 B2	11/26/02	Nishimura et al.			
	8	6,555,858 B1	04/29/03	Jones et al.			

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EXAMINER	DATE CONSIDERED
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	